

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:		)	Group Art Unit: 2823
	K. Koike et al.	)	Examiner: William D. Coleman
Application No. 10/712,333		)	I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP
Filed:	November 13, 2003	)	AMENDMENT, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 4, 2006.
For:	MASK-MAKING MEMBER AND ITS PRODUCTION METHOD, MASK AND ITS MAKING METHOD, EXPOSURE PROCESS, AND FABRICATION METHOD OF SEMICONDUCTOR DEVICE	)	Roxanne M. Swartz

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SUPPLEMENTAL RESPONSE TO SEPTEMBER 28, 2005 OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Office Action mailed September 28, 2005. Applicants respectfully request amendment of the patent application, and reconsideration and allowance of the pending claims.